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Type of Paper transmitted: Amendment under 37 C.F.R. §1.116

Applicant's Name: Toshiharu YANAGIDA

Serial No. (Control No.): 09/915,160

Examiner: Junghwa M. Im

Filing Date: July 25, 2001

Art Unit: 2811

Application Title: Semiconductor Apparatus and Process of Production Thereof

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Toshiharu YANAGIDA

Application No.: 09/915,160

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For: Semiconductor Apparatus and  
Process of Production Thereof

Group Art Unit: 2811

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**AMENDMENT UNDER 37 C.F.R. § 1.116**

Sir:

In response to the office action dated June 1, 2004, please consider the following amendments and remarks.